| Electronic Acknowledgement Receipt | | | | | |
|--------------------------------------|--|--|--|--|--|
| EFS ID: | 2078859 | | | | |
| Application Number: | 10018188 | | | | |
| International Application Number: | | | | | |
| Confirmation Number: | 7930 | | | | |
| Title of Invention: | Abrasive compound for cmp, method for polishing substrate and method for manufacturing semiconductor device using the same, and additive for cmp abrasive compound | | | | |
| First Named Inventor/Applicant Name: | Naoyuki Koyama | | | | |
| Correspondence Address: | Antonelli Terry Stout & Kraus - Suite 1800 1300 North Seventeenth Street Arlington VA 22209 US | | | | |
| Filer: | William Ivan Solomon/Kelli Harris | | | | |
| Filer Authorized By: | William Ivan Solomon | | | | |
| Attorney Docket Number: | 511.40998X00 | | | | |
| Receipt Date: | 13-AUG-2007 | | | | |
| Filing Date: | 18-DEC-2001 | | | | |
| Time Stamp: | 20:18:37 | | | | |
| Application Type: | U.S. National Stage under 35 USC 371 | | | | |
| Payment information: | | | | | |

Payment information:

| Submitted with Payment | yes |
|--|-------|
| Payment was successfully received in RAM | \$120 |
| RAM confirmation Number | 3669 |

File Listing:

| Document Number | Document Description | File Name | File Size(Bytes) /Message Digest | Multi Part /.zip | Pages (if appl.) |
|-----------------------------|----------------------|--|-------------------------------------|---------------------|---------------------|
| 1 Extension of Time | 40000V00 1MaFOT 1246 | 134728 | | | |
| 1 Extension of Time | 40998X00-1MoEOT.pdf | babbd52ea72972369e79c1d288f0fab7 e0ff68f3 | no | I | |
| Warnings: | | | | | |
| Information: | | | | | |
| Amendment - After Non-Final | 40998X00-Amend.pdf | 104123 | no | 9 | |
| Rejection | 40990X00-Amena.pai | 671155c5c857f35ea7cff91809f5d5fd56 534abe | 110 | <u>9</u> | |
| Warnings: | | | | | |
| Information: | | | | | |
| 3 Fee Worksheet (PTO-06) | fee-info.pdf | 8253 | no | 2 | |
| o ree worksheet (110 00) | ice illo.pai | 16ae62799a769946e8e657f65cd8338fa d28c8a5 | | _ | |
| Warnings: | | | | | |
| Information: | | | | | |
| | | Total Files Size (in bytes) | 247104 | | |

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.